Notice of References Cited

Application/Control No. 10/593,251	Applicant(s)/Patent Under Reexamination LIU, ENHUI		
Examiner	Art Unit		
OMAR GHOWRWAI	2416	Page 1 of 1	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2003/0112766 A1	06-2003	Riedel et al.	370/252
*	В	US-2001/0026554 A1	10-2001	Holler et al.	370/401
*	С	US-2004/0151114 A1	08-2004	Ruutu, Jussi Pekka	370/230
*	D	US-2004/0228363 A1	11-2004	Adamczyk et al.	370/468
*	Е	US-2003/0129988 A1	07-2003	Lee et al.	455/450
*	F	US-2002/0136162 A1	09-2002	Yoshimura et al.	370/229
*	G	US-2004/0131042 A1	07-2004	Lillie et al.	370/351
*	Н	US-2004/0022191 A1	02-2004	Bernet et al.	370/230
	1	US-			
	J	US-			
	К	US-			
	٦	US-			
	м	US-			

	FOREIGN PATENT DOCUMENTS					
*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	s					
	Т					

NON DATENT DOCUMENTS

* Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
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	w		
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